





Microscope objectives

Our objectives help you

Nikon's first microscope, released in 1925

focus on yours

Nikon is a leader in the development and manufacture of optical and digital imaging technology for advanced science and clinical research. With over a 100-year history of optical excellence, Nikon is committed to accelerating innovation in science and clinical imaging to improve healthcare and provide a better quality of life.

The switch from traditional film photography to digital imaging was a major milestone in the field of microscopy, opening up new possibilities in both application and technology. Introduction of digital imaging spurred significant technological changes including the development of objectives with enhanced optical quality and functionality to meet the new demands. Objective lenses are arguably the most important element in the microscope and Nikon continues to invest heavily in the development of objectives to meet the changing demands of science. Explore some of Nikon's newest developments in high-performance objectives in this brochure.

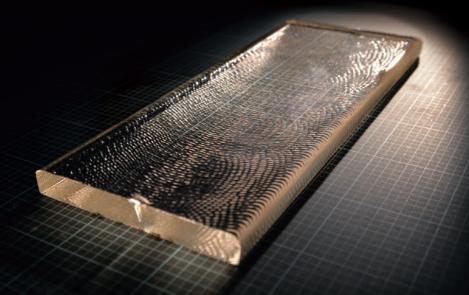




It Starts with the Glass

Nikon has been developing optical glass since its inception in 1917, and to this day, wholly owns and formulates all of its glass.

Optical glass starts as an ingot (shown on right) which is formed by blending rare earth elements and repeated melting, shaping and slow cooling to achieve a target refractive index. The glass ingots are precision-cut, polished and coated to produce lens elements for the objective.



Mastering Excellence

The front lens of high-performance objectives is hand-polished by Nikon's most highly skilled experts (shown on left), a technique requiring more than a decade to master.

By controlling the entire manufacturing process from glass formulation to assembly and alignment of lens elements, Nikon ensures the highest quality and performance of its objectives.

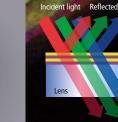
Objectives Inspired by Your Science

Produced to exacting standards, Nikon's objectives provide exceptional detail and clarity. The highest level of image quality can be achieved whether it be for routine tasks or cutting-edge research.

Anti-Reflective Nano Crystal Coat

Nano Crystal Coat is ultra-low refractive index thin film technology that applies a nanoparticle film used for the projection lens of Nikon's semiconductor manufacturing equipment. An extremely high antireflection effect is achieved by forming a low-density film with particles of a few nanometers to a dozen nanometers. It also lowers the reflection of vertically incident light compared to conventional antireflection film, achieves extremely high transmittance in a wide wavelength range, has an unprecedented effect with respect to ghosting and flares caused by obliquely incident light.







Cleared Tissue Imaging

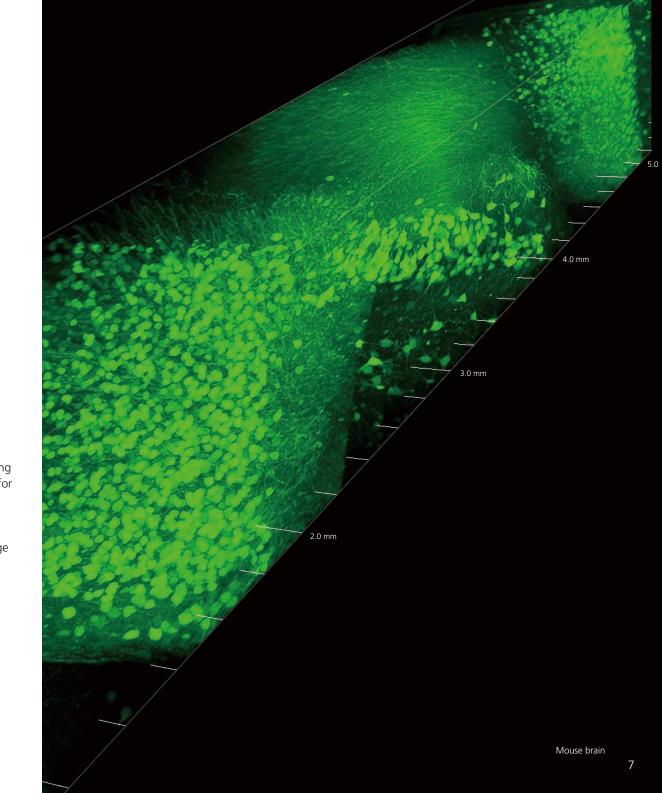


CFI90 20XC Glyc

Designed for deep imaging of cleared tissues

The unique CFI90 design results in an incredibly high N.A. while maintaining a large field of view and ultra-long working distance. Incorporates a correction collar for compensating for different refractive indices of clearing agents.

- NA: 1.00, WD: 8.20 mm
- Chromatic aberration correction from the visible to IR range
- High-transmittance Nano Crystal Coat
- Correction collar for spherical aberration correction



Cleared Tissue Imaging



CFI Plan Apochromat 10XC Glyc

Compatible with a wide range of immersion media and clearing agents

In addition to water and immersion oil, this objective lens is compatible with a variety of tissue clearing agents. The lens also features chromatic aberration correction over a broad spectral range and is compatible with the Ti2 inverted microscope.

- NA: 0.50, WD: 5.50 mm (upright) / 2.00 mm (inverted)
- Chromatic aberration correction from the visible to IR range
- High-transmittance Nano Crystal Coat
- Correction collar for spherical aberration correction



Multiphoton Imaging

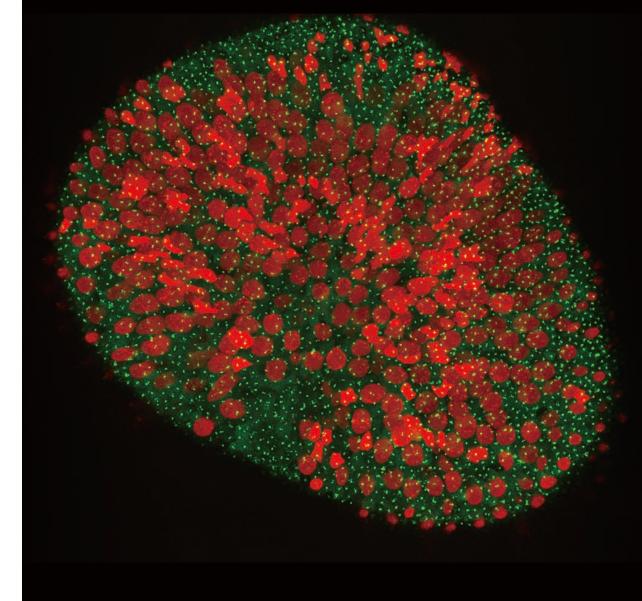


CFI75 Apochromat 25XC W 1300

Developed for deep brain applications

Best in class objective for multiphoton and electrophysiology applications. Offers ultra-long working distance and incredibly high N.A. for exceptional results every time.

- NA: 1.10, WD: 2.00 mm
- Chromatic aberration correction from the visible to near IR
- High-transmittance Nano Crystal Coat
- Correction collar for spherical aberration correction



Zebrafish larva

Multiphoton Imaging

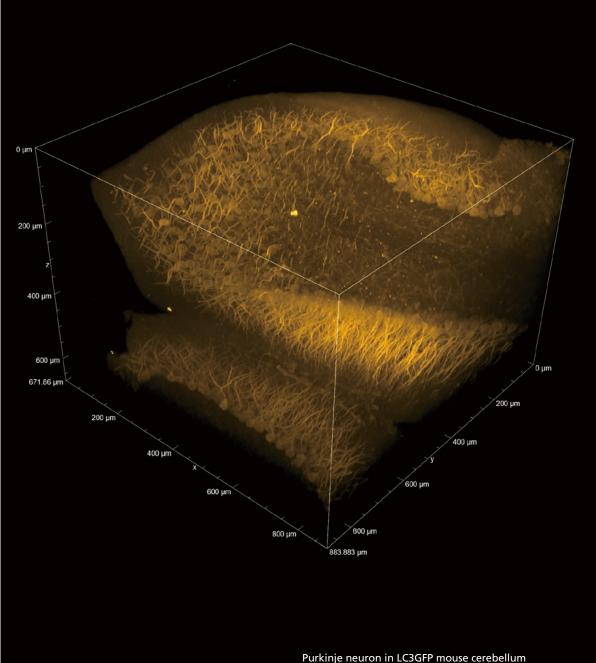


CFI75 Apochromat LWD 20XC W

Objective for large FOV multiphoton imaging

This objective can acquire bright multiphoton confocal images up to the edge of a large field of view of 22 mm. With a long working distance of 2.8 mm and a high numerical aperture of 1.00, it enables clear observation to deep within *in vivo* samples.

- NA: 1.00, WD: 2.8 mm
- Chromatic aberration correction from the visible to near IR range
- High-transmittance Nano Crystal Coat
- Correction collar for spherical aberration correction



Confocal Imaging



CFI Apochromat LWD Lambda S 20XC WI

A versatile objective for a wide range of applications

Combines high N.A., long working distance and large field of view for imaging thick, live samples. Chromatic aberration correction from visible to IR for multiphoton imaging as well.

- NA: 0.95, WD: 0.95 mm
- Chromatic aberration correction from the visible to IR range
- High-transmittance Nano Crystal Coat
- Correction collar for spherical aberration correction



Image courtesy of: Dr. L. Dubreil, Dr. J. Pichon and Pr MA Colle, CENN at PAnTher UMR703 INRAE/Oniris, Nantes France

Partner UMR/03 INRAE/Oniris, Nantes France

Confocal Imaging





CFI Plan Apochromat Lambda S 25XC/40XC Sil

High-resolution objectives for observing thick specimens

Silicone oil closely matches the refractive index of live cells, thereby minimizing spherical aberration and providing brighter, higher-resolution images. Unlike water, silicone oil demonstrates minimal evaporation at 37°C, thereby enabling extended, long-term time-lapse imaging experiments.

- NA: 1.05 (25XC)/1.25 (40XC), WD: 0.55 mm (25XC)/0.30 mm (40XC)
- Chromatic aberration correction in the visible range
- High-transmittance Nano Crystal Coat
- Correction collar for spherical aberration correction

100 µm Normal mouse embryos HeLa cell

Confocal Imaging



CFI Plan Apochromat IR 60XC WI

Incredible resolution and field flatness

This objective provides an NA of 1.27, the highest among 60X water immersion objectives, and achieves incredible field flatness. Corrects for chromatic aberration over a wide wavelength range up to IR, and supports various applications including multicolor live-cell confocal imaging, multiphoton imaging and laser tweezer applications.

- NA: 1.27, WD: 0.17 mm
- Chromatic aberration correction from the visible to IR range
- High-transmittance Nano Crystal Coat
- Correction collar for spherical aberration correction



Image of mouse embryo courtesy of: Dr. Yoshiteru Kai, Shonan Yume Clinic, Yamashita

Super-Resolution Imaging

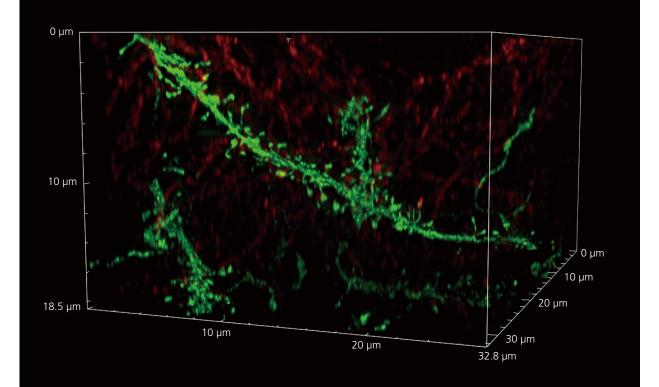


CFI SR HP Plan Apochromat Lambda S 100XC Sil

High-resolution silicone oil immersion objective for imaging live samples

Silicone oil more closely matches the refractive index of live cells compared to water or oil, thereby minimizing spherical aberration issues common to live cell imaging. In addition, the 100XC Sil lens achieves exceptional resolving power even at greater depths, making it well-suited for superresolution imaging of thicker specimen.

- NA: 1.35, WD: 0.30 mm
- Chromatic aberration correction in the visible range
- High-transmittance Nano Crystal Coat
- Correction collar for spherical aberration correction



Super-Resolution Imaging

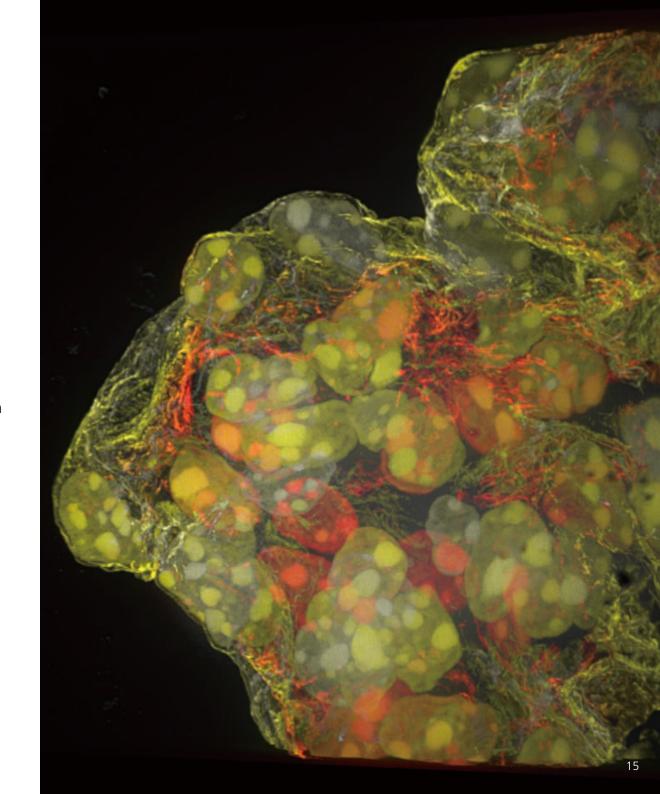


Auto Correction Collar

Quick and accurate spherical aberration correction

Achieving the highest quality point spread function is critical for super-resolution imaging. The ACC quickly moves lens elements in the objective to an optimal position based on the acquired point spread function to minimize spherical aberration.





Dendrites

High-Content Imaging

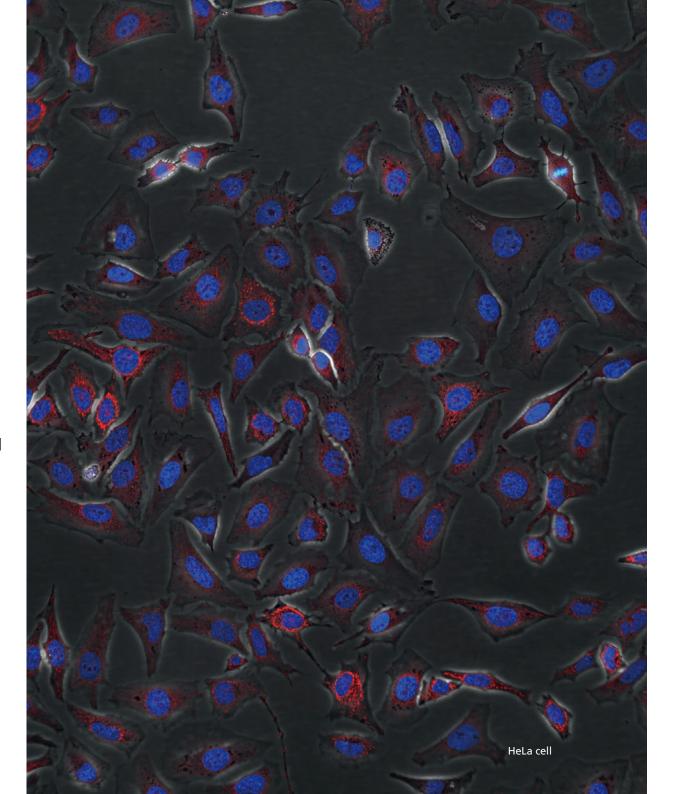


CFI S Plan Fluor LWD ADM 20XC

High NA and long WD objective designed for HC applications

This objective is compatible with thick plastic-bottom dishes and well-plates, and enables high-resolution phase-contrast and fluorescence observations. Its large FOV improves throughput of high-content applications.

- NA: 0.70, WD: 2.30-1.30 mm
- Chromatic aberration correction in the visible range
- Correction collar for spherical aberration correction



Pathological Examination



CFI Plan Apochromat Lambda D 40XC

Large field-of-view imaging with uniform brightness

This objective achieves uniform brightness up to the edge of the field of view, chromatic aberration correction from 405 nm upward, and improved resolution. The 25 mm field of view allows you to capture images of a large area of the sample, improving throughput.

- NA: 0.95, WD: 0.21 mm
- Chromatic aberration correction from the visible to near IR range
- High-transmittance Nano Crystal Coat
- Correction collar for spherical aberration correction

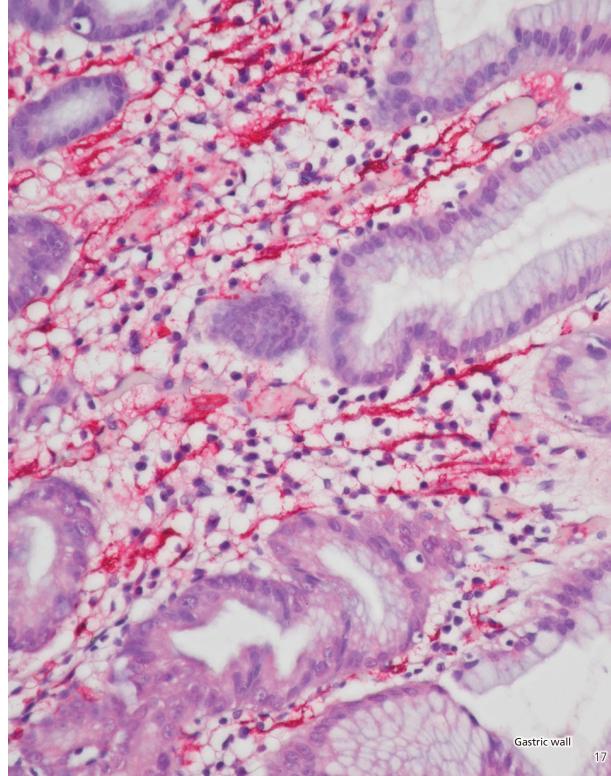


Image courtesy of: Nichirei Biosciences Inc.

A tool for finding the right objective

Nikon's online Objective Selector tool enables you to quickly and easily find the right objective for your application. Refine your search based on application, technique, objective class, immersion type, etc. Specifications for multiple objectives can be displayed in a single window for easy comparison.

https://www.microscope.healthcare.nikon.com/selectors/objectives





For OEM and DIY

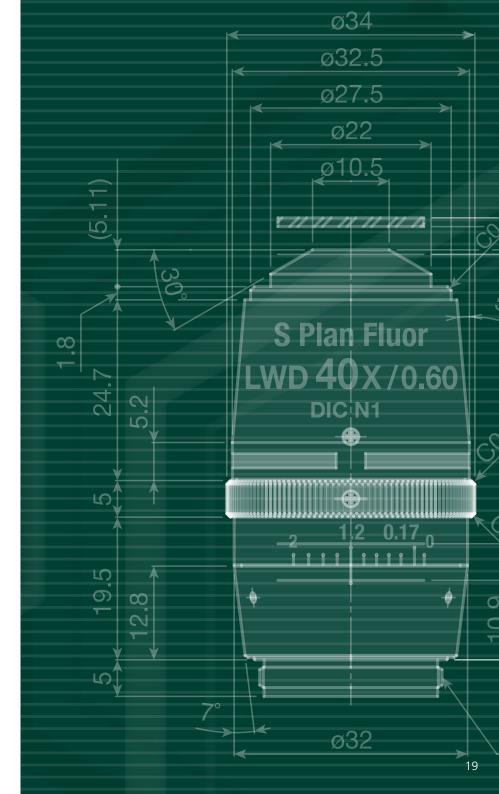
With over 100 years of experience in developing optical technology, Nikon offers a wide range of components that can fulfill almost any optical requirement.

Nikon develops products to the highest standards, from design to manufacture, to ensure we meet the needs of a wide variety of customers.

For detailed specifications including dimensions and transmission information, please refer to the following website.

https://www.microscope.healthcare.nikon.com/products/oem





As individual as you

Nikon offers a broad portfolio of objectives to meet your individual application needs. Explore some of the different objective series in the following pages.





















CFI Plan Apochromat Lambda D series

range from 405 nm to 850 nm, enabling highly accurate multicolor imaging.

| Use | Model | NIA | W.D. () | 0 | 0 | Duinbatin Int | Davideald | DIC | Dhara andurad | Delevision | | Fluorescence | | Ti2-E PFS |
|----------------------------|-------------------|------|-----------|--------------------------------------|---------------|---------------|-------------|-----|----------------|------------|------|---------------|-----|-----------|
| Use | Model | NA | W.D. (mm) | Cover glass thickness | Spring loaded | Brightfield | Darkfield | DIC | Phase contrast | Polarizing | UV | Visible light | NIR | 112-E PFS |
| | Lambda D 2X | 0.10 | 8.50 | 0/0.17 | | 0 | | | | | © CF | 0 | 0 | |
| | Lambda D 4X | 0.20 | 20.00 | 0/0.17 | | 0 | | | | | 0 | 0 | 0 | • |
| | Lambda D 10X | 0.45 | 4.00 | 0.17 | | 0 | \triangle | 0 | | • | 0 | 0 | 0 | • |
| | Lambda D 20X | 0.80 | 0.80 | 0.17 | ✓ | 0 | • | 0 | | • | 0 | 0 | 0 | • |
| | Lambda D 40XC | 0.95 | 0.21 | 0.11-0.23 | ✓ | 0 | • | 0 | | • | © CF | 0 | 0 | • |
| Brightfield (CFI Plan Apo) | Lambda D 60X Oil | 1.42 | 0.15 | 0.17 | ✓ | 0 | | 0 | EXT PH3-60x | • | 0 | 0 | 0 | • |
| | Lambda D 100X Oil | 1.45 | 0.13 | 0.17 | ✓ | 0 | | 0 | EXT PH3-100x | • | 0 | 0 | 0 | • |
| | Lambda S 25XC Sil | 1.05 | 0.55 | 0.11-0.23 | | 0 | • | 0 | | | • | 0 | | • |
| | Lambda S 40XC Sil | 1.25 | 0.30 | 0.13-0.21 (23°C) 0.15-0.23 (37°C) | | 0 | • | 0 | | | • | 0 | | • |
| | IR 60XC WI | 1.27 | 0.18-0.16 | 0.15-0.19 | ✓ | 0 | | 0 | EXT PH3-60x | 0 | • | 0 | 0 | • |
| | NCG 100X Oil | 1.40 | 0.16 | 0 | 1 | 0 | | 0 | | 0 | • | 0 | | |

Glossary C: with correction collar Oil: oil immersion

WI: water immersion W: water dipping

Mi: multi immersion Glyc: glycerin immersion Sil: silicone oil immersion Cover glass thickness

— : can be used without cover glass

0: use without cover glass

Possible with the following ∴ universal condenser (dry) and darkfield ring : above and darkfield condenser (dry)

: darkfield condenser (oil)

Outstanding image flatness and high resolution provide uniform image quality up to the edge of a large field of view of 25 mm, improving efficiency in image tiling and high content screening. Chromatic aberration has been corrected over a wide wavelength

Phase rings
PHL, PH1, PH2, PH3: condenser cassette modules.
EXT PH3, EXT PH4: external phase contrast modules for Ti2-E.

Fluorescence (UV)

: possible with visible light that has a longer wavelength than

the excitation light used for DAPI : suitable

: recommended for best results

340: high transmittance with an ultraviolet wavelength range of

CF: confocal imaging is possible at 488 nm and above

Brightfield/DIC/Polarizing/Fluorescence

: recommended for best results

Ti2-E PFS

■ : compatible with PFS

CFI Plan Apochromat VC

With its high degree of chromatic aberration correction and exceptional resolving power, the CFI Plan Apochromat VC 60XC WI is the perfect choice for multi-color fluorescence imaging as well as brightfield and DIC applications. In particular, axial chromatic aberration has been corrected in the short wavelength range, making this objective highly effective for confocal applications.



CFI Plan Apochromat VC 60XC WI

CFI SR series/CFI HP series/CFI SR HP series

Strict adjustment and inspection minimize the SR objective's asymmetric aberration, optimizing it for the N-SIM S super-resolution microscope. The HP objective has improved axial chromatic aberration correction and is compatible with the high-power lasers required for the fast blinks of fluorophores under the N-STORM super-resolution microscope. The SR HP objective offers both excellent optical performance and high durability against high power laser excitation, eliminating the need to switch objectives between the N-SIM S and N-STORM systems. AC objectives support the Auto Correction function of the Ti2-E inverted microscope.



CFI SR Plan Apochromat IR 60XC WI, CFI HP Plan Apochromat VC 100X Oil, CFI SR HP Apochromat TIRF 100XC Oil and CFI SR HP Plan Apochromat Lambda S 100XC Sil

| Use | Model | NA | W.D. (mm) | Cover glass thickness | Spring loaded | Brightfield | Darkfield | DIC | Phase contrast | Polarizing | Fluorescence | | | Ti2-E PFS |
|--|--------------------|------|--------------------------------------|--------------------------------------|---------------|-------------|-----------|-----|----------------|------------|--------------|---------------|----|-----------|
| USE | Wiodei | INA | VV.D. (IIIII) | Oover glass trickness | Spring loaded | Brightheid | Darkileid | DIC | | Polarizing | UV | Visible light | NR | 112-6 PF3 |
| Brightfield (CFI Plan Apo) | VC 60XC WI | 1.20 | 0.31-0.28 | 0.15-0.18 | 1 | 0 | | 0 | EXT PH3-60X | 0 | 0 | 0 | | • |
| Communication (OFI OR Plan Area) | IR 60XC WI | 1.27 | 0.18-0.16 | 0.15-0.19 | | 0 | | 0 | EXT PH3-60X | 0 | 0 | 0 | 0 | • |
| Super-resolution (CFI SR Plan Apo) | IR 60XAC WI | 1.27 | 0.18-0.16 | 0.15-0.19 | | 0 | | 0 | EXT PH3-60X | 0 | 0 | 0 | 0 | • |
| Super-resolution (CFI HP Plan Apo) | VC 100X Oil | 1.40 | 0.13 | 0.17 | ✓ | 0 | | 0 | EXT PH3-100X | 0 | • | 0 | | • |
| Super-resolution (CFI SR HP Plan Apo) | Lambda S 100XC Sil | 1.35 | 0.31-0.29 (23°C) 0.30-0.28 (37°C) | 0.15-0.19 | | 0 | | 0 | | 0 | 0 | 0 | | • |
| (OFI OR LIP A) | TIRF 100XC Oil | 1.49 | 0.16-0.10 (23°C) 0.15-0.09 (37°C) | 0.13-0.19 (23°C) 0.14-0.20 (37°C) | | 0 | | 0 | EXT PH4-100X | 0 | • | 0 | | • |
| Super-resolution (CFI SR HP Apo) | TIRF 100XAC Oil | 1.49 | 0.16-0.10 (23°C) 0.15-0.09 (37°C) | 0.13-0.19 (23°C) 0.14-0.20 (37°C) | | 0 | | 0 | EXT PH4-100X | 0 | • | 0 | | • |

CFI Apochromat Lambda S series

These high-numerical-aperture (NA) objectives provide chromatic aberration correction over wavelengths ranging from violet to near-infrared and are ideal for multicolor confocal imaging. The LWD Lambda S 20XC WI lens has a chromatic aberration correction range up to infrared. The transmittance of these lenses is enhanced over a wide wavelength range by utilizing Nano Crystal Coat technology.



CFI Apochromat Lambda S 40XC WI and CFI Apochromat LWD Lambda S 20XC WI/40XC WI

CFI Apochromat TIRF series

These objectives boast an unprecedented NA of 1.49 (using a standard coverslip and immersion oil), the highest resolution among Nikon objectives. Correction collars enable optimization of point spread functions for varying imaging temperatures, correcting spherical aberration when imaging at 23 and 37 degrees Celsius.



CFI Apochromat TIRF 60XC Oil and 100XC Oil

Multiphoton confocal objectives

These objectives are optimized for deep tissue imaging using a multiphoton confocal microscope, thanks to their ability to correct chromatic aberration up to near-IR range.

They provide both long WD and high NA, as well as high transmittance. The Glyc models have a correction collar for the refraction index of immersion liquids, and are compatible with various tissue clearing reagents that are used in neuroscience research.



CFI Plan Apochromat 10XC Glyc, CFI90 20XC Glyc, CFI75 Apochromat LWD 20XC W and 25XC W 1300

| Hee | Model | NA | W.D. (mm) | Cover glass thickness | Spring loaded | Brightfield | Darkfield | DIC | Phase contrast | Polarizing | | Fluorescence | | Ti2-E PFS |
|--|----------------------|------|--------------------------------------|--------------------------------------|---------------|-------------|-----------|--------|----------------|------------|----|---------------|-------------|-----------|
| Use | Wodel | INA | VV.D. (IIIII) | Cover glass trickness | Spring loaded | brightheid | Darkileid | DIC | Phase contrast | Polarizing | UV | Visible light | ght NIR Ti2 | 112-E PF3 |
| | LWD Lambda S 20XC WI | 0.95 | 0.99-0.90 | 0.11-0.23 | | 0 | • | 0 | | 0 | | 0 | 0 | • |
| Aultiphoton confocal (CFI Plan Apo) Aultiphoton confocal (CFI90) | LWD Lambda S 40XC WI | 1.15 | 0.61-0.59 | 0.15-0.19 | | 0 | • | 0 | EXT PH3-40X | 0 | 0 | 0 | | • |
| | Lambda S 40XC WI | 1.25 | 0.20-0.16 | 0.15-0.19 | ✓ | 0 | | 0 | EXT PH3-40X | 0 | 0 | 0 | | • |
| Evanescent (CFI Apo) | TIRF 60XC Oil | 1.49 | 0.16-0.10 (23°C) 0.13-0.07 (37°C) | 0.13-0.19 (23°C) 0.15-0.21 (37°C) | | 0 | | 0 | EXT PH4-60X | 0 | • | 0 | | • |
| | TIRF 100XC Oil | 1.49 | 0.16-0.10 (23°C) 0.15-0.09 (37°C) | 0.13-0.19 (23°C) 0.14-0.20 (37°C) | | 0 | | 0 | EXT PH4-100X | 0 | • | 0 | | • |
| Multiphoton confocal (CFI Plan Apo) | 10XC Glyc | 0.50 | Upright: 5.50 Inverted: 2.00 | 0-0.17 | | 0 | 0 | | | | | 0 | 0 | |
| Multiphoton confocal (CFI90) | 20XC Glyc* | 1.00 | 8.20 | 0 | | • *** | | | | | | | 0 | |
| Multiphoton confocal (CFI75 Apo) | LWD 20XC W** | 1.00 | 2.8 | 0-0.17 | | 0 | | | | | • | 0 | 0 | |
| | 25XC W* | 1.10 | 2.00 | 0 | | 0 | • | 0 **** | | 0 | 0 | 0 | 0 | |
| | 25XC W 1300* | 1.10 | 2.00 | 0 | | 0 | • | O **** | | 0 | 0 | 0 | 0 | |

^{*} Dedicated for FN1 and Ni-E focusing nosepiece type

^{**} Dedicated for AX R MP multiphoton confocal system
*** Can only be used as a finder (chromatic aberration is corrected above 588 nm)

^{****} Also compatible with near-infrared DIC

CFI Plan Fluor series

Featuring a high transmission rate, especially in the ultraviolet wavelength, and flatness of field, this series is designed for fluorescence observation and imaging. These objectives can function as multipurpose objectives for brightfield, fluorescence, simple polarizing, and DIC observations.







CFI Plan Fluor DLL 10X, 20X, 40X and 100X Oil

CFI Super Fluor series

This CFI Super Fluor series ensures an extra-high transmission rate of ultraviolet wavelengths down to 340nm for fluorochromes like indo-1 and fura-2. Also, these objectives have improved S/N ratios for short wavelengths and have high NA, making the fluorescence images they produce significantly sharper and brighter.



CFI Super Fluor 10X, 20X, 40XC and 40X Oil

| Hee | Model | NA | M/D (mm) | Cayor glass thiskness | Coring looded | Brightfield | Darkfield | DIC | Phase contrast | Polarizing | Flu | orescence | Ti2-E PFS |
|--|--------------|-----------|--|-----------------------|---------------|-------------|-------------------------|-----|----------------|------------|-------|---------------|-----------|
| Use | Model | NA NA | W.D. (mm) | Cover glass thickness | Spring loaded | Brightfield | Darkfield | DIC | Phase contrast | Polarizing | UV | Visible light | TIZ-E PFS |
| Phase contrast (CFI Plan Fluor) | 4X | 0.13 | 17.20 | _ | | 0 | | | | • | 0 | 0 | |
| | 10X | 0.30 | 16.00 | 0.17 | | 0 | \triangle | 0 | | 0 | 0 | 0 | • |
| | 20X | 0.50 | 2.10 | 0.17 | | 0 | $\bigcirc left$ | 0 | | 0 | 0 | 0 | |
| | 20XC MI | 0.75 | 0.51-0.35 (oil) 0.51-0.34 (glycerin) 0.49-0.33 (water) | 0-0.17 | ✓ | 0 | 0 | 0 | | 0 | 0 | 0 | |
| Brightfield (CFI Plan Fluor) | 40X | 0.75 | 0.66 | 0.17 | ✓ | 0 | $\circ \bullet$ | 0 | | 0 | 0 | 0 | • |
| ightfield (CFI Plan Fluor) | 40X Oil | 1.30 | 0.24 | 0.17 | ✓ | 0 | | 0 | EXT PH3-40X | 0 | 0 | 0 | • |
| | 60XC | 0.85 | 0.40-0.31 | 0.11-0.23 | ✓ | 0 | • | 0 | | 0 | 0 | 0 | |
| | 60XS Oil | 0.50-1.25 | 0.22 | 0.17 | ✓ | 0 | $\circ \bullet$ | 0 | EXT PH3-60X | 0 | 0 | 0 | |
| | 100X Oil | 1.30 | 0.16 | 0.17 | ✓ | 0 | | 0 | | 0 | 0 | 0 | • |
| | 100XS Oil | 0.50-1.30 | 0.16 | 0.17 | ✓ | 0 | 0 | 0 | | 0 | 0 | 0 | |
| | DL 4XF | 0.13 | 16.50 | 1.20 | | 0 | | | O PHL | | 0 | 0 | |
| | DLL 10X | 0.30 | 16.00 | 0.17 | | 0 | \triangle | | © PH1 | | 0 | 0 | • |
| | DL 10XF | 0.30 | 15.20 | 1.20 | | 0 | \triangle | | © PH1 | | 0 | 0 | • |
| OF Discours | DLL 20X | 0.50 | 2.10 | 0.17 | | 0 | 0 | | © PH1 | | 0 | 0 | |
| Phase contrast (CFI Plan Fluor) | DLL 40X | 0.75 | 0.66 | 0.17 | ✓ | 0 | $\circ \bullet$ | | © PH2 | | 0 | 0 | |
| | DLL 100X Oil | 1.30 | 0.16 | 0.17 | ✓ | 0 | | | © PH3 | | 0 | 0 | • |
| | DM 40X | 0.75 | 0.66 | 0.17 | ✓ | 0 | $\bigcirc led$ | | © PH2 | | 0 | 0 | |
| | BM 40X | 0.75 | 0.66 | 0.17 | ✓ | 0 | $\bigcirc lacktriangle$ | | © PH2 | | 0 | 0 | |
| Apodized phase contrast (CFI Plan Fluor) | ADH 100X Oil | 1.30 | 0.16 | 0.17 | ✓ | 0 | | | © PH3 | | 0 | 0 | • |
| | 4X | 0.20 | 15.50 | - | | 0 | | | | • | ◎ 340 | 0 | • |
| | 10X | 0.50 | 1.10 | 0.17 | ✓ | 0 | $\bigcirc lacktriangle$ | 0 | | • | ◎ 340 | 0 | |
| Brightfield (CFI Super Fluor) 20 44 40 | 20X | 0.75 | 1.00 | 0.17 | ✓ | 0 | 0 | 0 | | • | ◎ 340 | 0 | • |
| | 40XC | 0.90 | 0.34-0.26 | 0.11-0.23 | ✓ | 0 | • | 0 | | • | ◎ 340 | 0 | |
| | 40X Oil | 1.30 | 0.19 | 0.17 | ✓ | 0 | | 0 | | • | ◎ 340 | 0 | • |
| | 100XS Oil | 0.50-1.30 | 0.20 | 0.17 | 1 | 0 | 0 | | | • | ◎ 340 | 0 | |

CFI S Plan Fluor series

The broadband multilayer coating realizes high transmittance from ultraviolet to near-infrared wavelengths, with superior chromatic correction. The correction collar allows these objectives to be used with a diverse range of culture vessels and specimen thicknesses. High-quality images with no aberrations can be obtained under a broad range of illumination techniques.



CFI S Plan Fluor LWD 20XC and LWD ADM 20XC



CFI S Plan Fluor ELWD 20XC, 40XC and 60XC



CFI S Plan Fluor ELWD ADM 20XC, 40XC and ADL 60XC

Nikon Advanced Modulation Contrast (NAMC) series

Nikon has developed dedicated objectives for advanced modulation contrast. Colorless and transparent samples can be observed in high relief with a plastic dish, which is not possible in DIC observation. The direction of contrast can be matched to S Plan Fluor ELWD NAMC objectives, thereby allowing optimal contrast selection for techniques like microinjection and ICSI.





| Use | Model | NA | W.D. (mm) | Cover glass thickness | Spring loaded | Brightfield | Darkfield | DIC | Phase | Polarizing | Fluorescence | | Ti2-E PFS |
|-----------------------------------|----------------|------|---------------|-----------------------|----------------|-------------|-------------------------|-----|----------|-------------|--------------|---------------|-----------|
| 036 | Wiodei | '\ | VV.D. (IIIII) | Oover glass trickress | Opining loaded | Drigittield | Darkileiu | DIO | contrast | 1 Glarizing | UV | visible light | HZ-ETTS |
| | LWD 20XC | 0.70 | 2.30-1.30 | 0-1.80 | | 0 | 0 | 0 | | 0 | 0 | 0 | • |
| B: 145 11 (051 0 B) | ELWD 20XC | 0.45 | 8.20-6.90 | 0-2.00 | | 0 | $\bigcirc lacktriangle$ | 0 | | 0 | 0 | 0 | • |
| Brightfield (CFI S Plan Fluor) | ELWD 40XC | 0.60 | 3.60-2.80 | 0-2.00 | | 0 | 0 | 0 | | 0 | 0 | 0 | • |
| | ELWD 60XC | 0.70 | 2.60-1.80 | 0.10-1.30 | | 0 | $\bigcirc lacktriangle$ | 0 | | 0 | 0 | 0 | |
| | LWD ADM 20XC | 0.70 | 2.30-1.30 | 0-1.80 | | 0 | 0 | | © PH2 | | 0 | 0 | • |
| Apodized phase contrast | ELWD ADM 20XC | 0.45 | 8.20-6.90 | 0-2.00 | | 0 | 0 | | © PH1 | | 0 | 0 | • |
| (ĊFI S Plan Fluor) | ELWD ADM 40XC | 0.60 | 3.60-2.80 | 0-2.00 | | 0 | $\bigcirc lacktriangle$ | | © PH2 | | 0 | 0 | • |
| ÖFI S Plan Fluor) | ELWD ADL 60XC | 0.70 | 2.60-1.80 | 0.10-1.30 | | 0 | $\bigcirc lacktriangle$ | | © PH2 | | 0 | 0 | |
| Advanced modulation contrast | ELWD NAMC 20XC | 0.45 | 8.20-6.90 | 0-2.00 | | 0 | | | | | 0 | 0 | |
| (CFI S Plan Fluor) | ELWD NAMC 40XC | 0.60 | 3.60-2.80 | 0-2.00 | | 0 | | | | | 0 | 0 | |
| | NAMC 10XF | 0.25 | 6.20 | 1.20 | | 0 | | | | | | • | |
| dvanced modulation contrast (CFI) | LWD NAMC 20XF | 0.40 | 3.10 | 1.20 | | 0 | | | | | | • | |
| | LWD NAMC 40XC | 0.55 | 2.70-1.70 | 0-2.00 | | 0 | | | | | | • | |

CFI Plan Achromat series

CFI Plan Achromat series provides incredible image flatness, with chromatic aberration corrected throughout the entire visible spectrum. These objectives are suitable not only for observation but also for capturing images.



CFI Plan 1X, 2X, 4X, 10X, 20X, 40X and 100X Oil



CFI Plan DL 10X, 20X, 40X and 100X Oil

Water Dipping Series

Sharper tips and broad approach angles provide improved accessibility for manipulator control. Aberrations are corrected even in the infrared range for high-magnification objectives, making them suitable for multi-photon imaging using infrared light.



CFI Plan Fluor 10XW, CFI75 LWD 16XW, CFI Apochromat NIR 40XW/60XW and CFI Plan 100XC W

| Use | Model | NA | W.D. (mm) | Cover glass thickness | Spring loaded | Brightfield | Darkfield | DIC | Phase | Polarizing | Flu | orescence | Near- infrared DIC |
|-----------------------------|-------------|------|--------------|-----------------------|---------------|-------------|-------------------------|-----|----------|------------|-----|---------------|---------------------|
| Ose | Model | I NA | W.D. (IIIII) | Cover glass trickness | Spring loaded | brightheid | Darkileid | DIC | contrast | Polarizing | UV | Visible light | Ivear- Illiaied Dio |
| | 1X | 0.04 | 3.20 | _ | | 0 | | | | • | | • | |
| | 2X | 0.06 | 7.50 | - | | 0 | | | | • | | • | |
| | 4X | 0.10 | 30.00 | _ | | | | | | • | | 0 | |
| | 10X | 0.25 | 10.50 | - | | 0 | \triangle | | | • | | 0 | |
| Brightfield (CFI Plan) | 20X | 0.40 | 1.20 | 0.17 | | 0 | $\circ \bullet$ | | | • | | 0 | |
| Brightheid (GFI Flair) | 40X | 0.65 | 0.56 | 0.17 | ✓ | 0 | 0 | | | • | | 0 | |
| | 50X Oil | 0.90 | 0.35/0.18 | -/0.17 | ✓ | 0 | • | | | • | | 0 | |
| | 100X Oil | 1.25 | 0.20 | 0.17 | ✓ | 0 | | | | • | | 0 | |
| | NCG 40X | 0.65 | 0.48 | 0 | ✓ | 0 | $\bigcirc lacktriangle$ | | | • | | 0 | |
| | NCG 100X | 0.90 | 1.00 | 0 | ✓ | 0 | • | | | • | | 0 | |
| | DL 10X | 0.25 | 10.50 | _ | | 0 | \triangle | | ○ PH1 | • | | • | |
| Phase contrast (CFI Plan) | DL 20X | 0.40 | 1.20 | 0.17 | | 0 | 0 | | O PH1 | • | | • | |
| Friase Contrast (CFI Fiair) | DL 40X | 0.65 | 0.56 | 0.17 | ✓ | 0 | $\bigcirc left$ | | O PH2 | • | | • | |
| | DL 100X Oil | 1.25 | 0.20 | 0.17 | ✓ | 0 | | | © PH3 | • | | • | |
| DIC (CFI Plan Fluor) | 10X W | 0.30 | 3.50 | 0 | | | \triangle | 0 | | 0 | 0 | 0 | 0 |
| IR-DIC (CFI Apo) | NIR 40X W | 0.80 | 3.50 | 0 | | 0 | • | 0 | | 0 | • | 0 | 0 |
| TIN-DIC (CIT Apo) | NIR 60X W | 1.00 | 2.80 | 0 | | 0 | • | 0 | | 0 | | 0 | 0 |
| DIC (CFI Plan) | 100XC W | 1.10 | 2.50 | 0 | | 0 | • | 0 | | 0 | | 0 | 0 |
| DIC (CFI75) | LWD 16X W * | 0.80 | 3.00 | 0 | | 0 | • | 0 | | 0 | 0 | 0 | 0 |

* Dedicated for FN1 and Ni-E focusing nosepiece type

CFI Achromat series

This series of objectives provide dramatic correction for chromatic aberration, spherical aberration and coma. Image flatness is significantly improved.

Nikon specifically developed ADL series for phase contrast observations by using its proprietary apodization process to improve the objective's phase ring. Imaging cell division is often impeded by unwanted halos due to the sample thickness. ADL mitigates this effect for clearer observation of mitotic events.



CFI 4X and 10X, CFI LWD 20X, CFI 40X, CFI NCG 60X and CFI 100X Oil CFI DL 10X, CFI LWD DL 20X, CFI DL 40X and 100X Oil





CFI ADL 10XF, CFI LWD ADL 20XF, 40XF and 40XC

| Use | Model | NA | W.D. (mm) | Cover glass thickness | Spring loaded | Brightfield | Darkfield | DIC | Phase contrast | Polarizing | Fluorescence UV Visible light | Ti2-E PFS |
|-------------------------------|--------------|-----------|-----------|-----------------------|---------------|-------------|-------------------------|-----|-------------------|------------|--------------------------------|-----------|
| | 4X | 0.10 | 30.00 | _ | | 0 | | | | • | 0 | |
| | 10X | 0.25 | 7.00 | - | | 0 | \triangle | | | • | 0 | |
| | LWD 20X | 0.40 | 3.90 | 0.17 | | 0 | $\bigcirc lacktriangle$ | | | • | 0 | |
| | 40X | 0.65 | 0.65 | 0.17 | ✓ | 0 | $\bigcirc lacktriangle$ | | | • | 0 | |
| Brightfield (CFI) | LWD 40XC | 0.55 | 2.70-1.70 | 0-2.00 | | 0 | $\bigcirc lacktriangle$ | | | • | 0 | |
| | 60X | 0.80 | 0.30 | 0.17 | ✓ | 0 | • | | | • | 0 | |
| | NCG 60X | 0.80 | 0.30 | 0.17 | 1 | 0 | $\bigcirc lacktriangle$ | | | • | 0 | |
| | 100X Oil | 1.25 | 0.23 | 0.17 | ✓ | 0 | | | | • | Ō | |
| | 100XS Oil | 0.50-1.25 | 0.23 | 0.17 | ✓ | 0 | $\bigcirc lacktriangle$ | | | • | 0 | |
| | DL 10X | 0.25 | 7.00 | - | | 0 | \triangle | | © PH1 | • | • | |
| | LWD DL 20X | 0.40 | 3.90 | 0.17 | | 0 | $\bigcirc lacktriangle$ | | © PH1 | • | • | |
| | LWD DL 20XF | 0.40 | 3.10 | 1.20 | | 0 | | | © PH1 | • | • | |
| Phase contrast (CFI) | DL 40X | 0.65 | 0.65 | 0.17 | ✓ | 0 | $\bigcirc lacktriangle$ | | ○ PH2 | • | • | |
| | LWD DL 40XC | 0.55 | 2.70-1.70 | 0-2.00 | | 0 | $\bigcirc lacktriangle$ | | © PH2 | • | • | |
| | DL 100X Oil | 1.25 | 0.23 | 0.17 | ✓ | 0 | | | ○ PH3 | • | • | |
| | BM 10X | 0.25 | 7.00 | 0.70 | | 0 | | | © PH1 | • | • | |
| | ADL 10XF | 0.25 | 6.20 | 1.20 | | 0 | | | © PH1 | • | • | |
| Anadizad phase contract (CEI) | LWD ADL 20XF | 0.40 | 3.10 | 1.20 | | 0 | | | © PH1 | • | • | |
| Apodized phase contrast (CFI) | LWD ADL 40XF | 0.55 | 2.10 | 1.20 | | 0 | | | O PH1 | • | • | |
| | LWD ADL 40XC | 0.55 | 2.70-1.70 | 0-2.00 | | 0 | 0 | | © PH2 | • | • | |

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